

Supporting information

Large-area synthesis of monolayer WS₂ and its ambient-sensitive photo-detecting performance

Changyong Lan, Chun Li*, Yi Yin, Yong Liu

State Key Laboratory of Electronic Thin Film and Integrated Device, School of Optoelectronic Information, University of Electronic Science and Technology of China, Chengdu, 610054, China

Supporting Figure S1

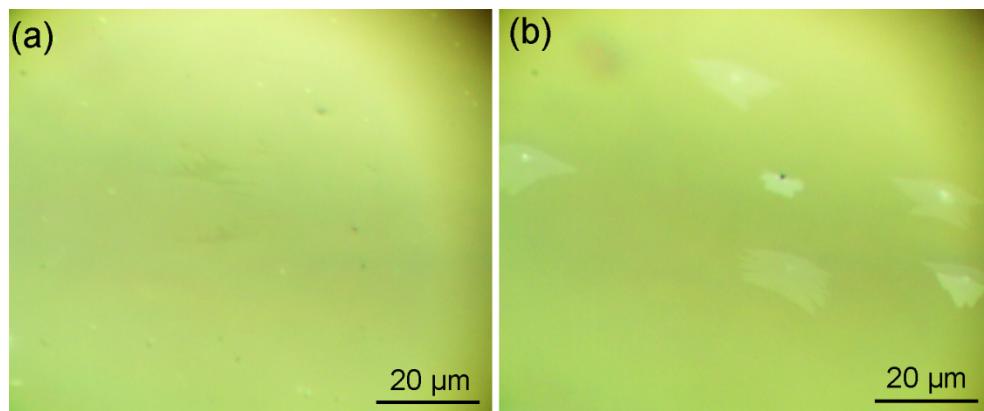


Figure S1. Optical microscopy images of as-grown monolayer WS₂ film and flakes on sapphire substrates with (a) and without seeding (b).

* Author to whom any correspondence should be addressed. E-mail: lichun@uestc.edu.cn

Supporting Figure S2

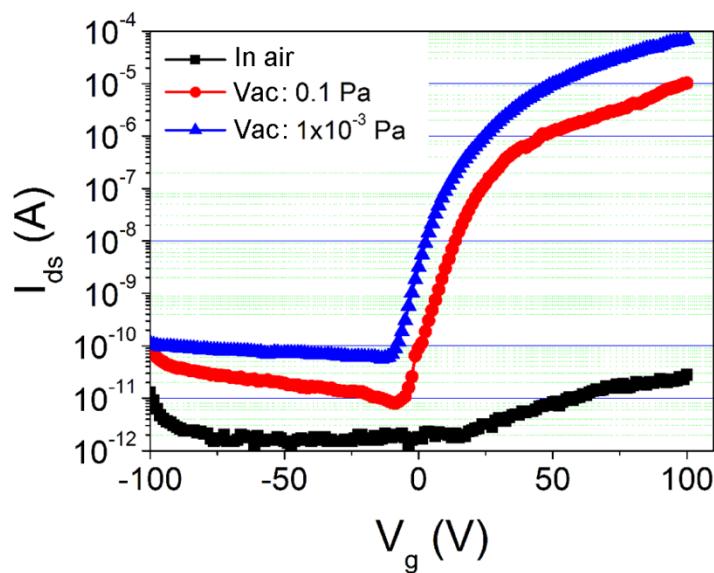


Figure S2. Transport characteristics (I_{ds} - V_g) in air and in vacuum. The drain-source voltate (V_{ds}) is 20 V.

Supporting Table S1.

Table S1. FET performance in different pressures.

Measure	Mobility	Sub-threshold Swing	
Environment	(cm ² /V·s)	ON/OFF ratio	(V/decade)
In air	1.87×10^{-7}	10	50
Vacuum of 0.1Pa	0.21	10^6	6.6
Vacuum of 1×10^{-3} Pa	0.91	10^6	4.9

Supporting Table S2

Table S2. Summary of the literature reports on the electrical transport and photoresponse performance of atomically thin WS₂ crystals.

Sample	Contact electrode	L/W (μm)	Mobility ($\text{cm}^2/\text{V}\cdot\text{s}$)	On/Off ratio	R	Response time	Ref.
WS ₂ nanoflakes (exfoliated)	Ti/Au	20/15	12	10	5.7 A/W (633 nm)	<20ms	1
Single layer WS ₂ (exfoliated)	Ti/Au	6.8/2.5	~1-2 (10 hours High temperature annealing in 10 ⁻⁴ Pa vacuum)	10 ⁶	N/A	N/A	2
Multilayer layer							
WS ₂ (exfoliated)	Au	5/2	234	10 ⁸	N/A	N/A	3
Single layer WS ₂	Ni/Au	6.5/4	9.5	N/A	N/A	N/A	4
Single layer WS ₂ (CVD-grown)	Ti/Au	1/(N/A)	0.01 (in air)	10 ⁵	N/A	N/A	5
Few layer films (CVD-grown)	Ti/Au	50/500	N/A	N/A	21.2 $\mu\text{A}/\text{W}$ (647 nm)	~5.3ms (in air)	6
Multilayer WS ₂ (CVD-grown)	Ti/Au	2.5/2.0	N/A	10 ⁵	N/A	N/A	7
Monolayer WS ₂ (CVD-grown)	Al	30/230	0.91 (1×10 ⁻³ Pa)	10 ⁶	mA/W (532 nm, 1×10 ⁻³ Pa)	<4.5ms (in air)	This work

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